EE4371 - Introduction to MEMS

**EE 4371** Introduction to MEMS (3 semester credit hours) This course will target an audience of motivated senior-level undergraduates, with the goal of providing an introduction to M/NEMS fabrication techniques, selected device applications, and the design tradeoffs in developing systems. Prerequisites: **CHEM 1311** and (**MECH 3310** and **MECH 3350** and **PHYS 2126** and **PHYS 2326**) or (**CE 3110** or **EE 3110**) and (**CE 3310** or **EE 3310**) and **PHYS 2125** and **PHYS 2325**. (Same as **MECH 4370**) (3-0) Y